



# Single-Event Effects

## *Part 3 – Measuring SEE*

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Luddy School of Informatics, Computing, and Engineering  
Indiana University

# Module 3: Objective and Outcomes

- This module will
  - Introduce the basic principles of accelerator facilities used for SEE testing
  - Describe the properties of ground test facilities related to microelectronics test requirements
  - Outline the necessary measurements for obtaining accurate SEE models
  - Provide a practical guide for preparing for an SEE experiment
- Student Outcomes
  - 1. Students will demonstrate an understanding of critical ground test properties and variables and how they influence test performance requirements.
  - 2. Students will be able to describe the beam structure, method of delivery, and the beam's influence on an experiment.

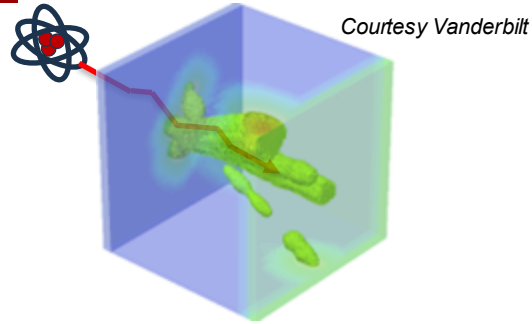
# Outline

- Measuring SEE
  - SEE Cross Section and LET Threshold
  - Modeling SEE Cross Section
  - Sensitive Volume
  - From Experiment to On-orbit Rate Estimate
- Practical Considerations

05

# MEASURING SEE

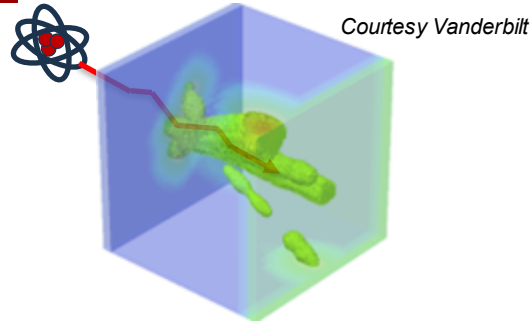
# Single-Event Effects In Microelectronics



## Single-Event Effects (SEE):

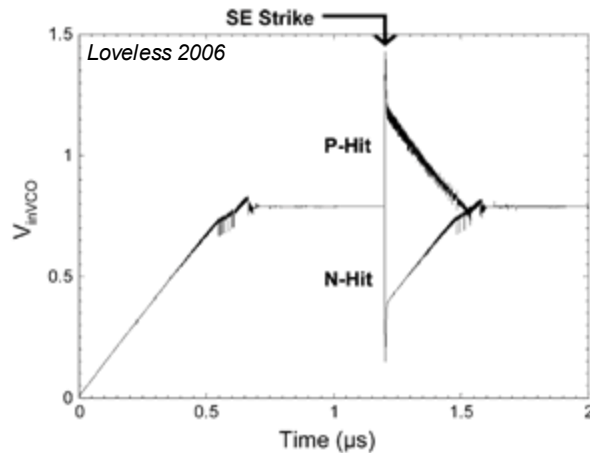
- **Caused by the interaction of a single energetic particle**
- **SEE are determined by:**
  - Charge generation
  - Charge collection
  - Circuit response
- **Types:**
  - Non-destructive:*
    - Single-event transients
    - Single-event upsets (soft errors)
    - Single-event functional interrupt
    - Multiple-bit upsets
  - Destructive:*
    - Single-event latchup
    - Single-event burnout
    - Single-event gate rupture
    - Single-event snap-back

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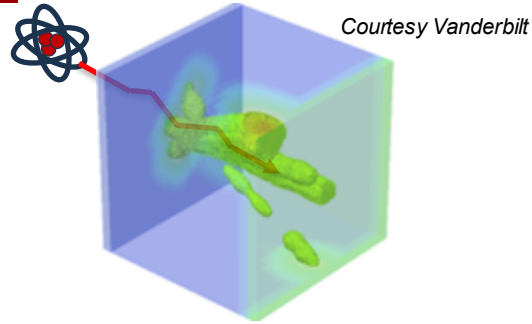
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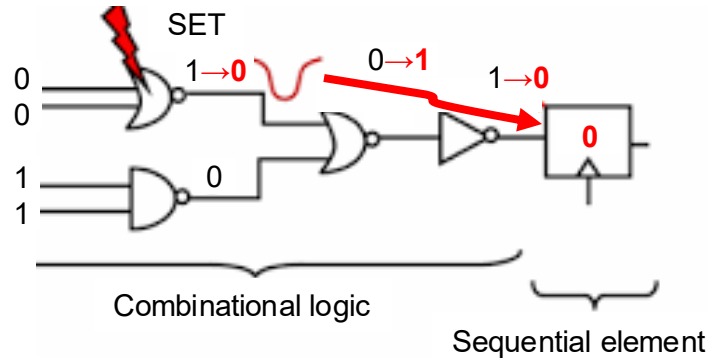
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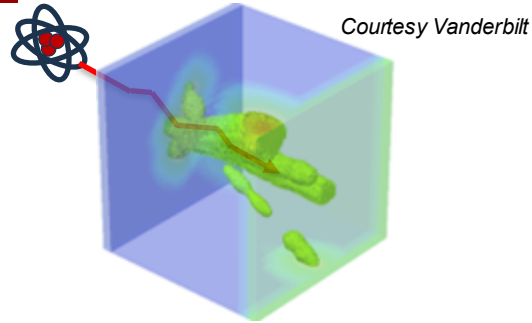
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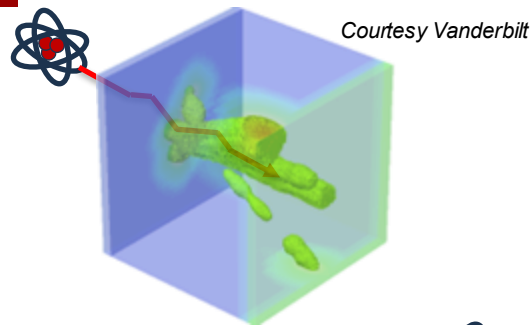
Control Registers/Logic

0	0	1	1	0	1	0
1	1	0	0	0	0	1
0	0	0	1	1	0	1
0	0	1	1	1	1	1

Conceptual Memory



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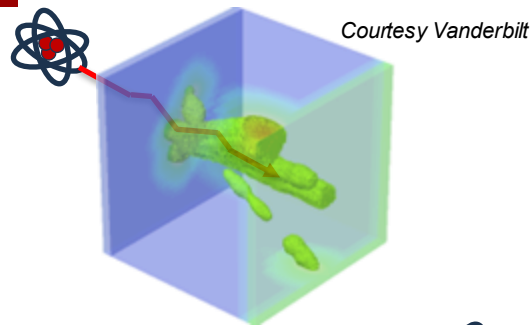
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Example of an SEU causing a bit flip in a conceptual memory

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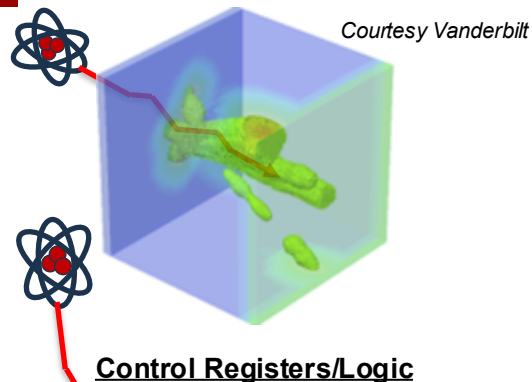
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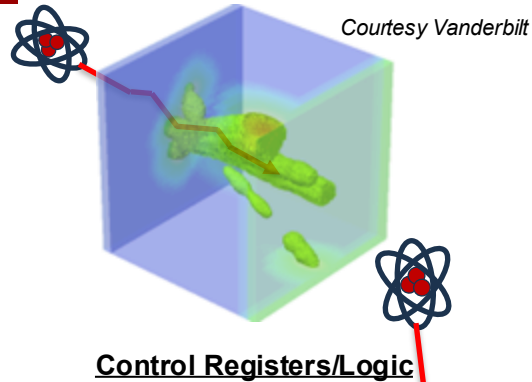
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Example of an SEU causing a bit flip in a conceptual memory

1

The diagram shows a CMOS inverter on a p-substrate. The NMOS transistor has a p+ substrate contact, n+ source, and n+ drain. The PMOS transistor has a p+ source, p+ substrate contact, and n+ drain. Parasitic resistances are indicated:  $R_{\text{sub}}^{\text{substrate}}$  for the NMOS source,  $R_{\text{n-well}}$  for the PMOS source, and  $R_{\text{sub}}^{\text{substrate}}$  for the PMOS substrate contact. The output node is connected to the drains of both transistors. The input node is connected to the gates of both transistors. The output node is also connected to a load capacitor  $C_L$ . The input node is connected to a signal source  $V_{\text{in}}$ . The output node is connected to a signal source  $V_{\text{out}}$ . The input node is also connected to a signal source  $V_{\text{in}}$ . The output node is also connected to a signal source  $V_{\text{out}}$ .

Cross-section of typical CMOS technology showing **parasitic thyristor** that can be triggered into low impedance state

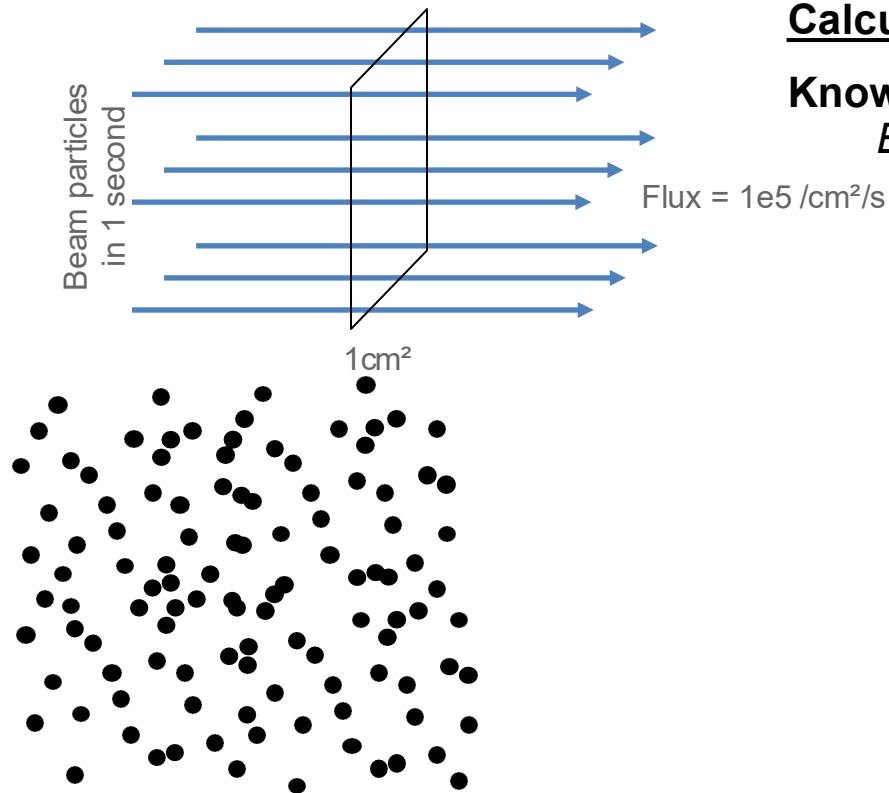
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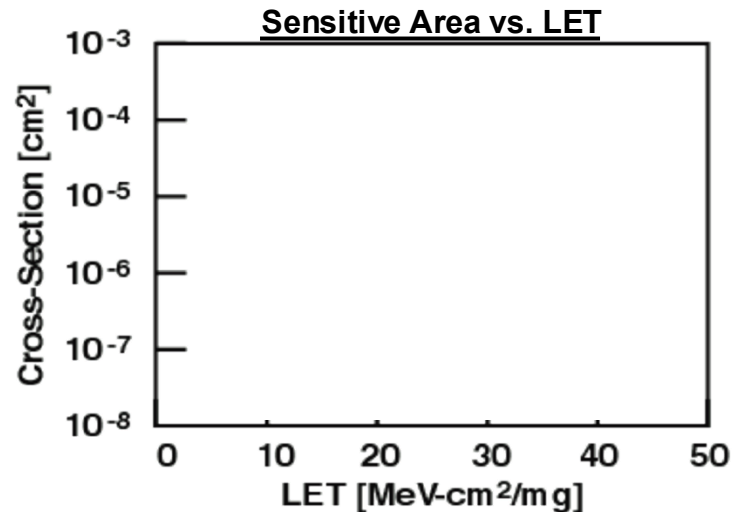
# SEE Cross-Section



## Calculation of SEE Cross-Section

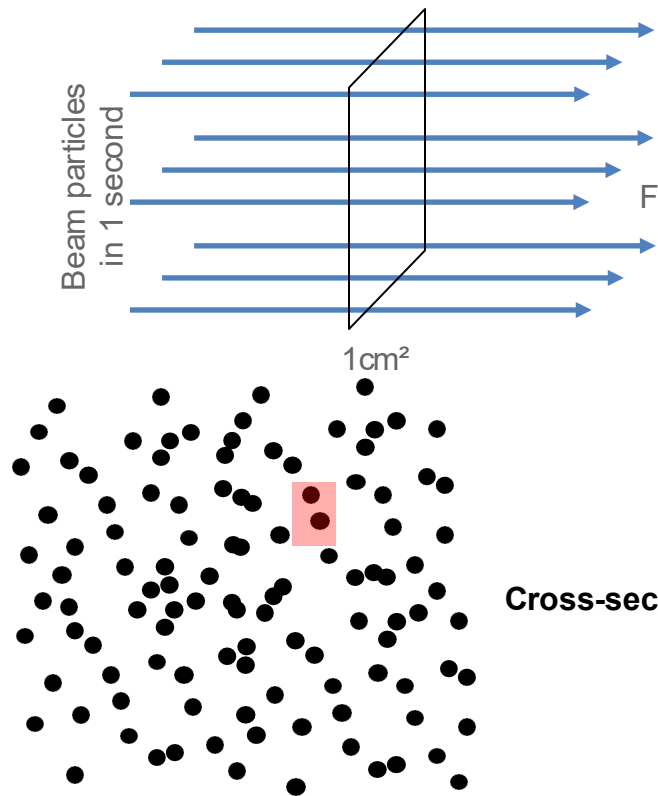
**Known Fluence (Ions)**

*Ex. 1000 sec of irradiation to  $1e8 \text{ ions/cm}^2$*



**LET = Linear Energy Transfer**

# SEE Cross-Section

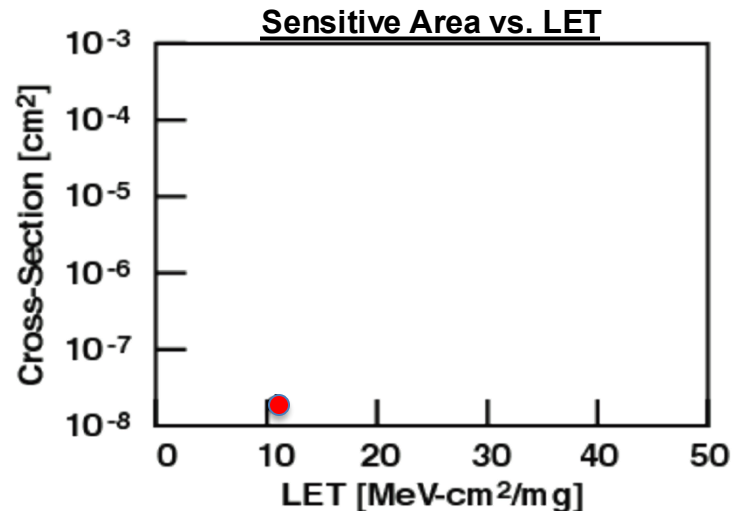


$$\text{Cross-section} = \frac{2 \text{ upsets/device}}{1e8 \text{ ions/cm}^2} = 2e-8 \text{ cm}^2/\text{device}$$

## Calculation of SEE Cross-Section

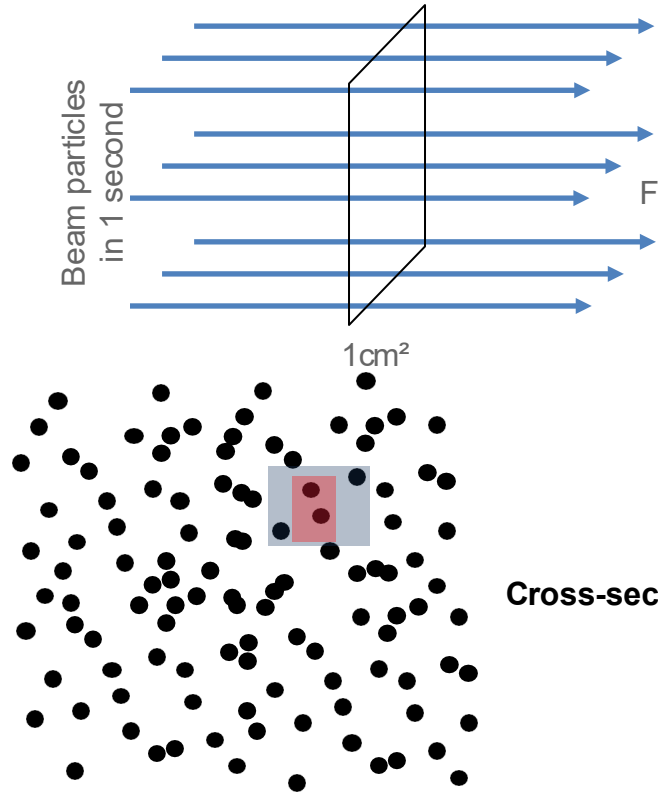
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# SEE Cross-Section



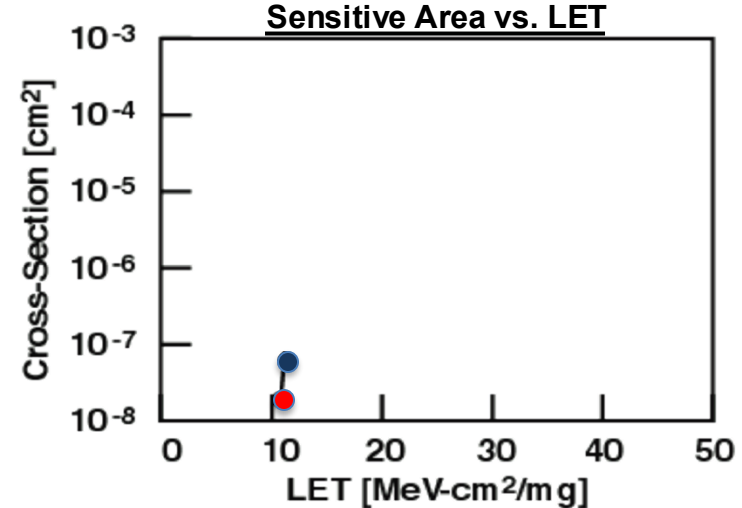
Flux =  $1e5 / \text{cm}^2/\text{s}$

## Calculation of SEE Cross-Section

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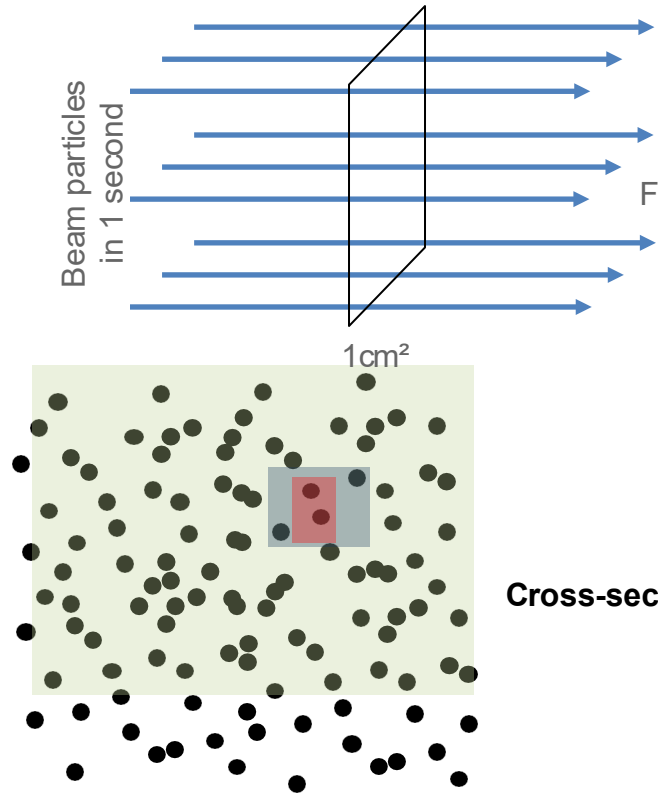
$$\begin{aligned}\text{Cross-section} &= \frac{4 \text{ upsets/device}}{1e8 \text{ ions}/\text{cm}^2} \\ &= 4e-8 \text{ cm}^2/\text{device}\end{aligned}$$



LET = Linear Energy Transfer



# SEE Cross-Section



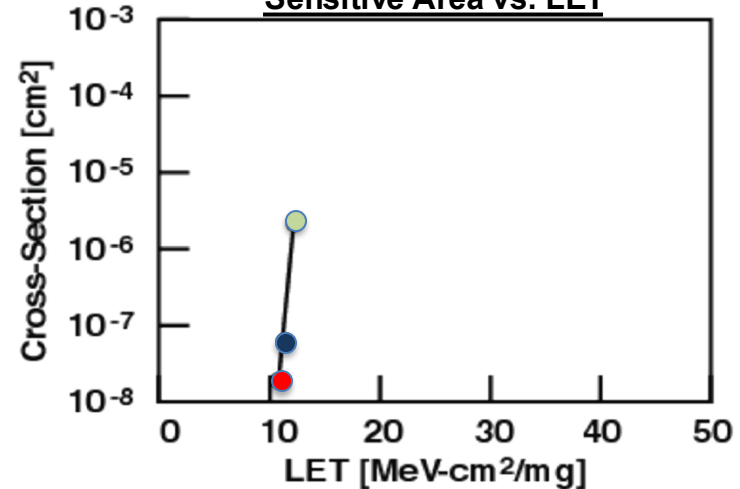
$$\text{Cross-section} = \frac{120 \text{ upsets/device}}{1e8 \text{ ions/cm}^2} = 1.2e-6 \text{ cm}^2/\text{device}$$

## Calculation of SEE Cross-Section

**Known Fluence (Ions)**

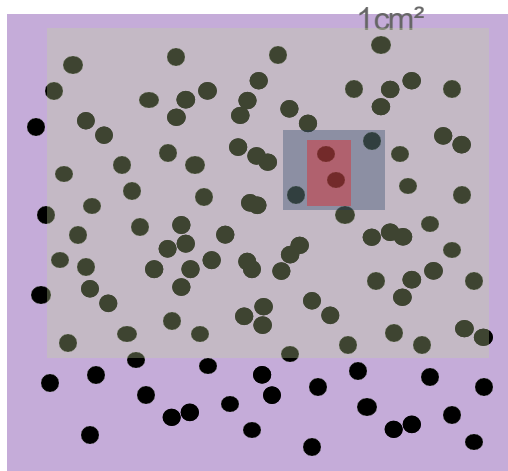
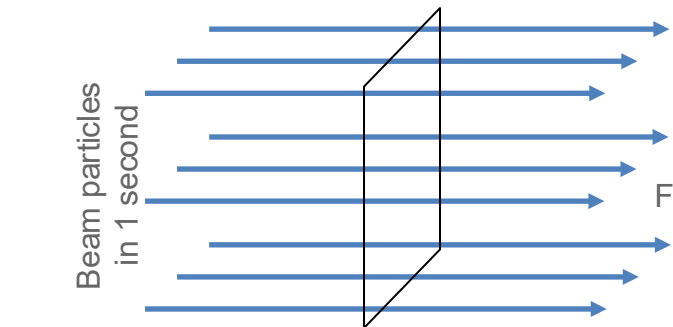
*Ex. 1000 sec of irradiation to 1e8 ions/cm<sup>2</sup>*

## Sensitive Area vs. LET



LET = Linear Energy Transfer

# SEE Cross-Section

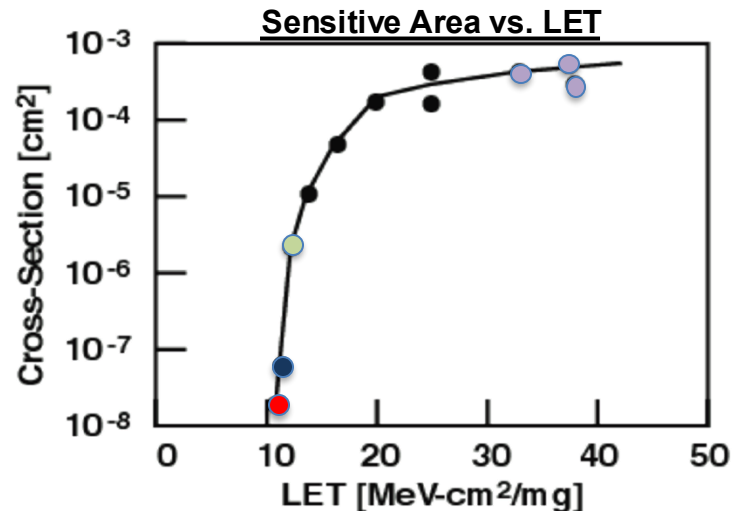


Cross-sections are measured vs. LET until the LET threshold (onset LET) and saturated (or limiting) cross-section can be determined

## Calculation of SEE Cross-Section

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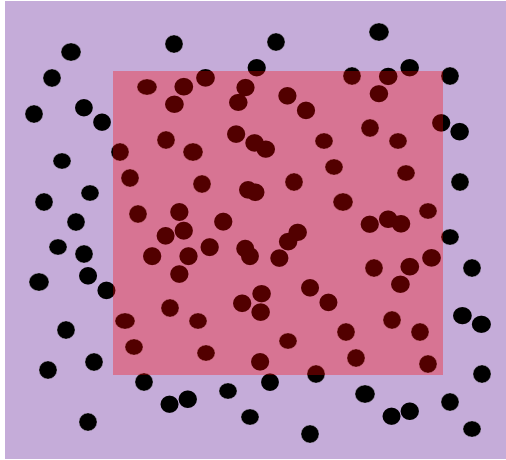


**LET = Linear Energy Transfer**

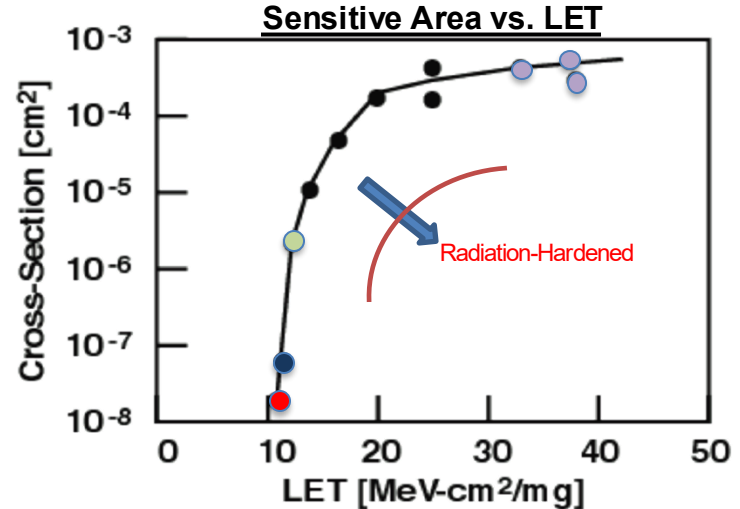
# SEE Cross-Section

Radiation hardening aims to increase the LET threshold and decrease the saturation cross-section

Rad-Hard Parts may have very few events and require long exposures – this can be particularly challenging in complex parts

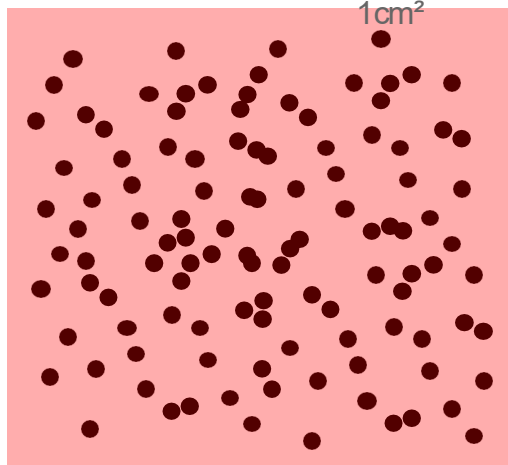
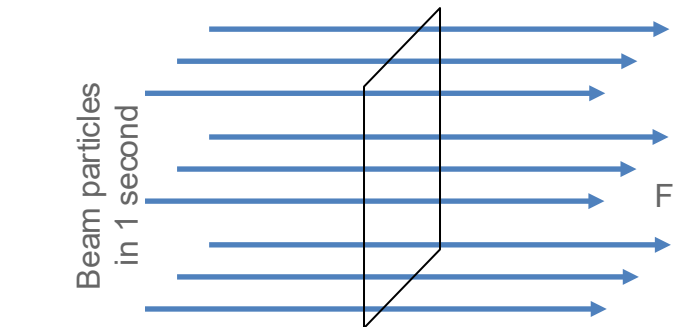


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# SEE Cross Section



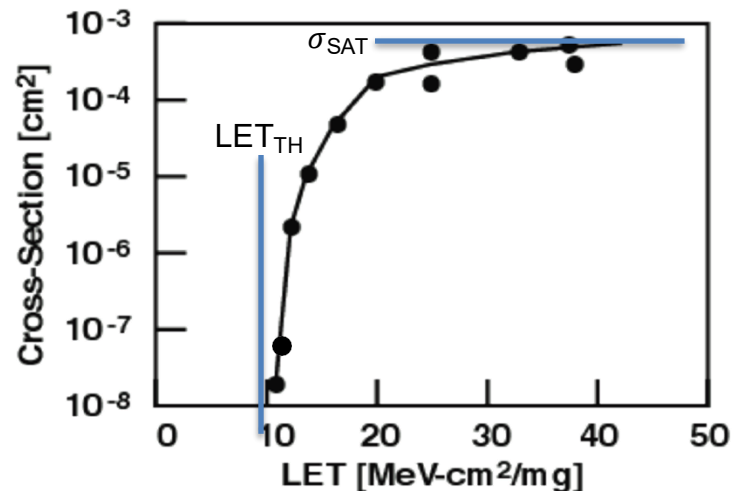
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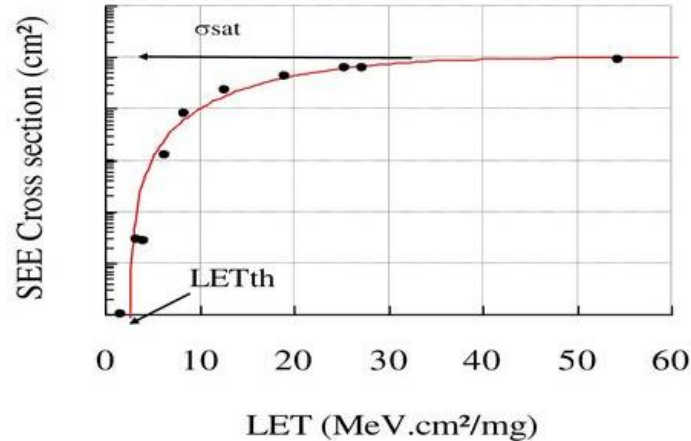
## Sensitive Area vs. LET



**LET = Linear Energy Transfer**

# Modeling the SEE Cross Section – more in Module 12

- Model cross-section data with a Weibull curve (use a semi-log y scale)
- Fit the model by minimizing the sum of the squared residuals



Source: [ESA presentation by C. B. Polo](#)

$$[\text{cm}^2] \rightarrow \sigma = \frac{N_{\text{events}}}{\text{Fluence}} \leftarrow [N_{\text{particules}}/\text{cm}^2]$$

Fit with Weibull (integral form)

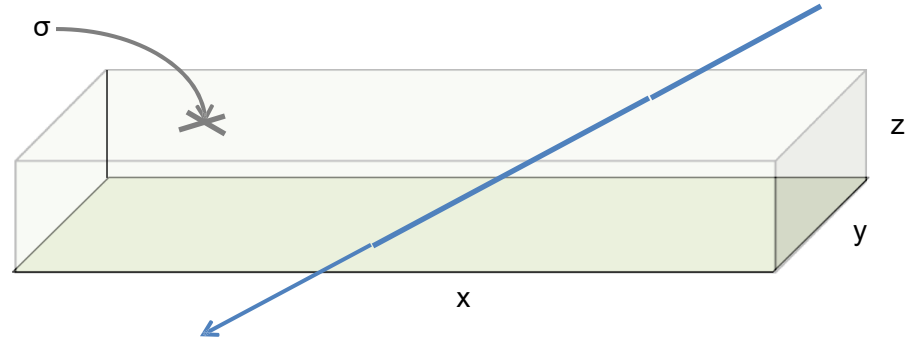
$$\sigma = \sigma_{\text{sat}} \left( 1 - \exp\left(\frac{\text{LET} - \text{LET}_{\text{th}}}{W}\right)^S \right)$$

W and S are fitting parameters

SEE cross-section is a crucial input for in-orbit SEE rate prediction.

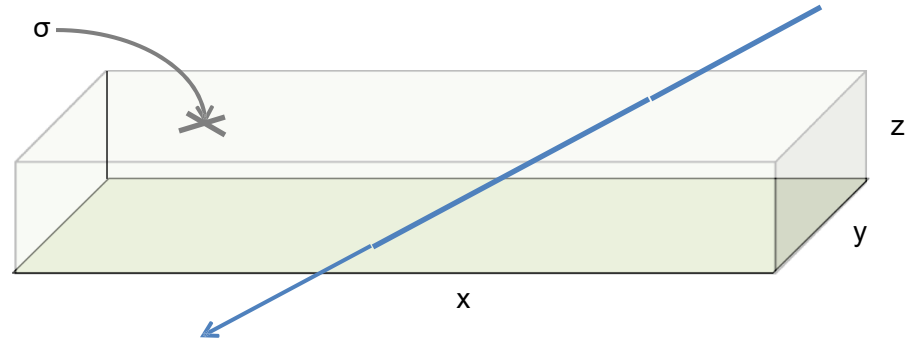
# Rectangular Parallel Piped (RPP) Model

- Cross-Section:
  - $\sigma = x * y$
  - The top-down area of the SV (or sensitive area)
- Depth of sensitive volume,  $z$
- Path Length, distance traveled by ion through the SV ( ——— )



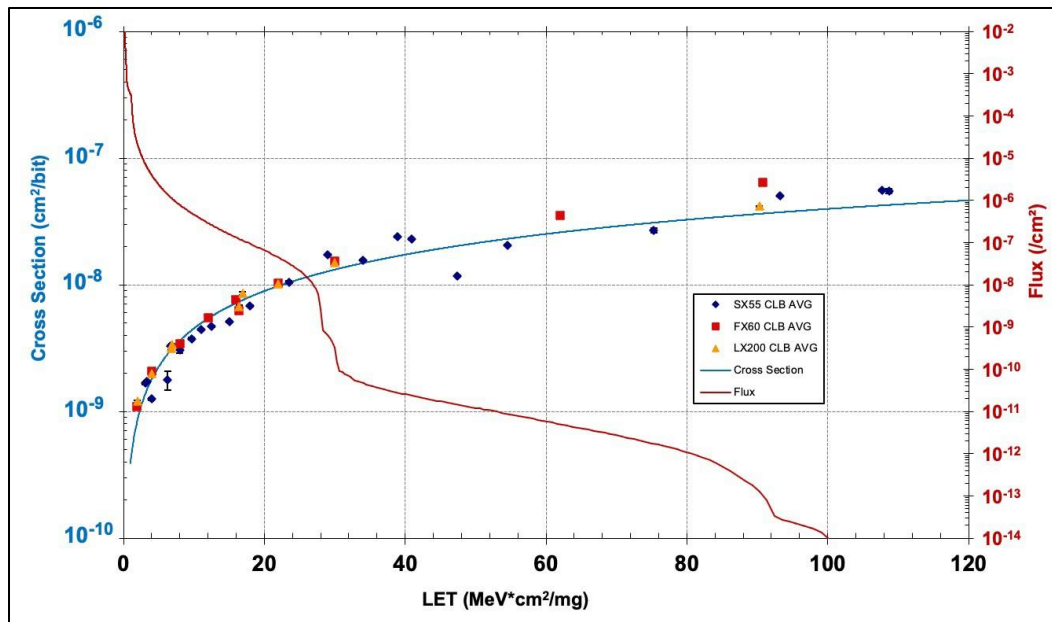
# Measuring SV?

- You may need to estimate the SV to use error rate modeling tools
- Experimentally:
  - Measure  $N$ , the number of SEE, during a run to fluence, Calculate:
    - $\sigma = N/\Phi$
    - $x = y = \sqrt{\sigma}$
    - $z$
- Many organizations use a "rule of thumb" for determining  $z$ 
  - Example
    - Typical:  $z = x/5$
    - Worst-case:  $z = x/100$



# From Experiment to On-orbit Rate Estimate

*more on this later*



$$Rate = \int \underbrace{\frac{dflux(LET, \theta)}{dLET}}_{\text{environment}} \times \underbrace{\sigma(LET, \theta)}_{\text{device response}} d\theta dLET$$



06

# PRACTICAL CONSIDERATIONS

# Example: LBNL 88" Cyclotron BASE Facility



# About the facility

- 88" Cyclotron built in the 60s
- Heavy ions available in “cocktails”
- Example 16 MeV/amu cocktail below – don’t rely on quoted LET values!

Ion	Cocktail (AMeV)	Energy (MeV)	Z	A	Chg. State	% Nat. Abund.	LET (Entrance) (MeV/mg/cm <sup>2</sup> )
He*	16	43.46	2	3	+1	0.000137	0.11
N	16	233.75	7	14	+5	99.63	1.16
O	16	277.33	8	17	+6	0.04	1.54
Ne	16	321.00	10	20	+7	90.48	2.39
Si	16	452.10	14	29	+10	4.67	4.56
Cl	16	539.51	17	35	+12	75.77	6.61
Ar	16	642.36	18	40	+14	99.600	7.27
V	16	832.84	23	51	+18	99.750	10.90
Cu	16	1007.34	29	63	+22	69.17	16.53
Kr	16	1225.54	36	78	+27	0.35	24.98
Xe*	16	1954.71	54	124	+43	0.1	49.29

Source: [LBNL Cyclotron Ion Cocktails](#)



# About the facility

- Advantages
  - Changing ions (LET) is fast and easy
    - Usually just a few minutes
    - Not the case at other facilities!
  - Flux can be tuned with attenuators
  - They have a sparkling water machine



# About the facility

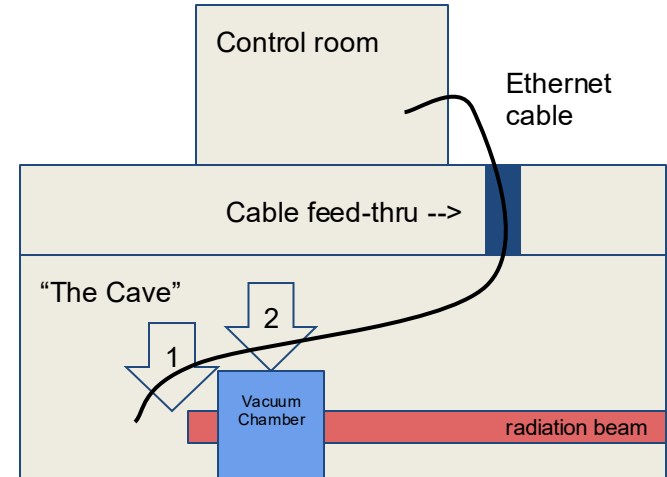
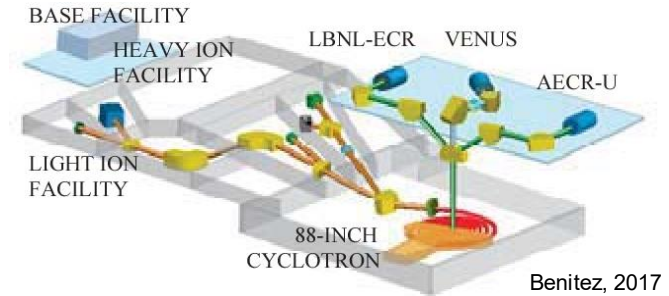
- Disadvantages
  - The beam goes down often for hours at a time
  - The beam runs 24 hours/day so you lose a lot of sleep





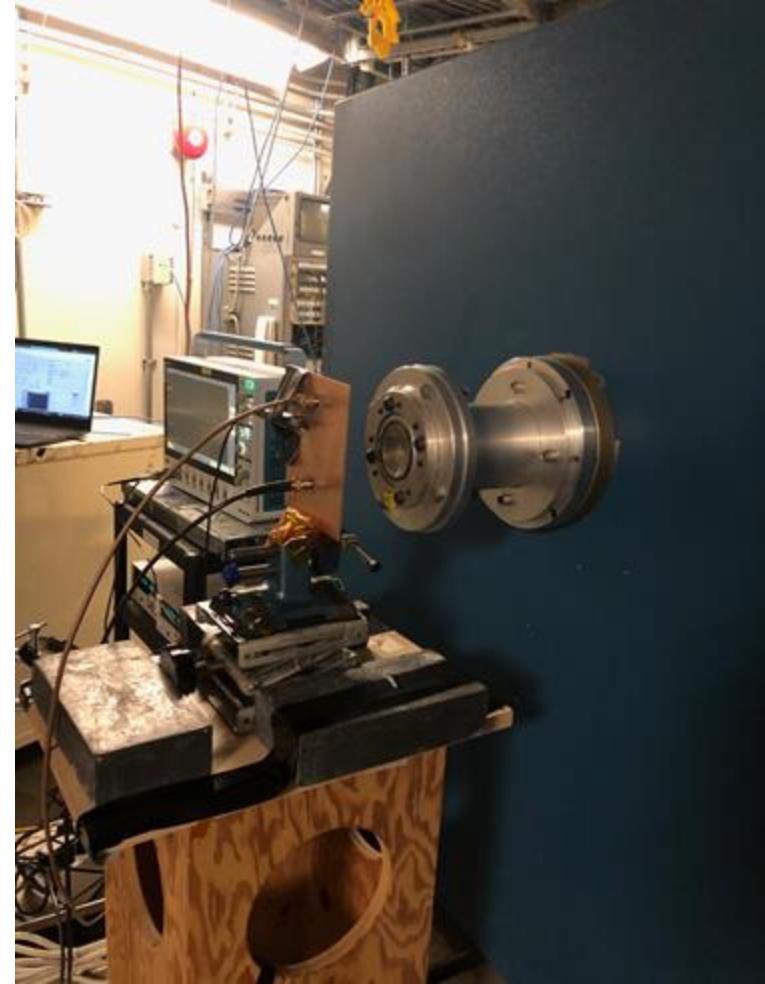
# Setting up your system

- The control room sits directly above the beam chamber
- There is a tube into the chamber where you can run cables
- 60 feet of cables will be plenty to reach your test system
- Outside the vacuum chamber (position 1) you do not need to worry about bulkhead connectors
- Using the vacuum chamber (position 2) you need to know what connections will be available and will need extra cables
- Some cocktails (such as 10 MeV/amu) require the vacuum chamber



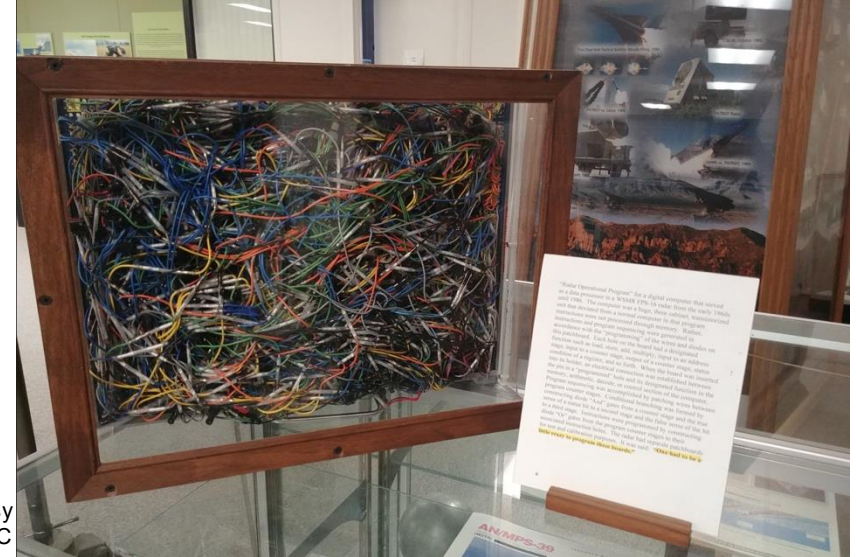
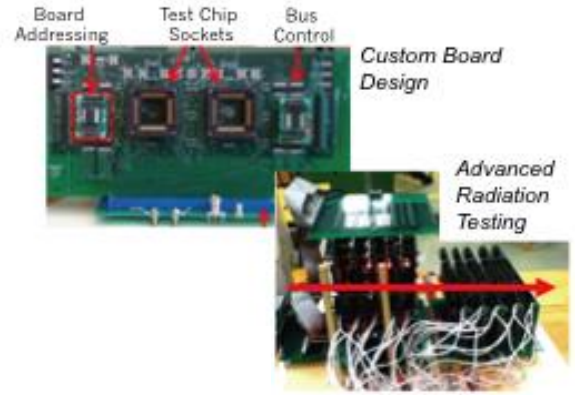
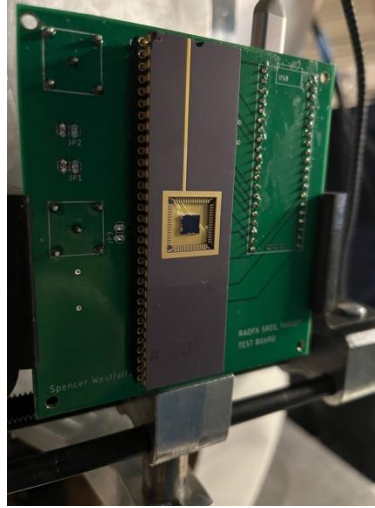
# Setting up your system

Pro tip: They will have plenty of clamps and mounts there. You should worry more about cabling



# Cabling

Pro tip: Bring extra cables (of every type), connectors. Use the cables you have tested with and verified



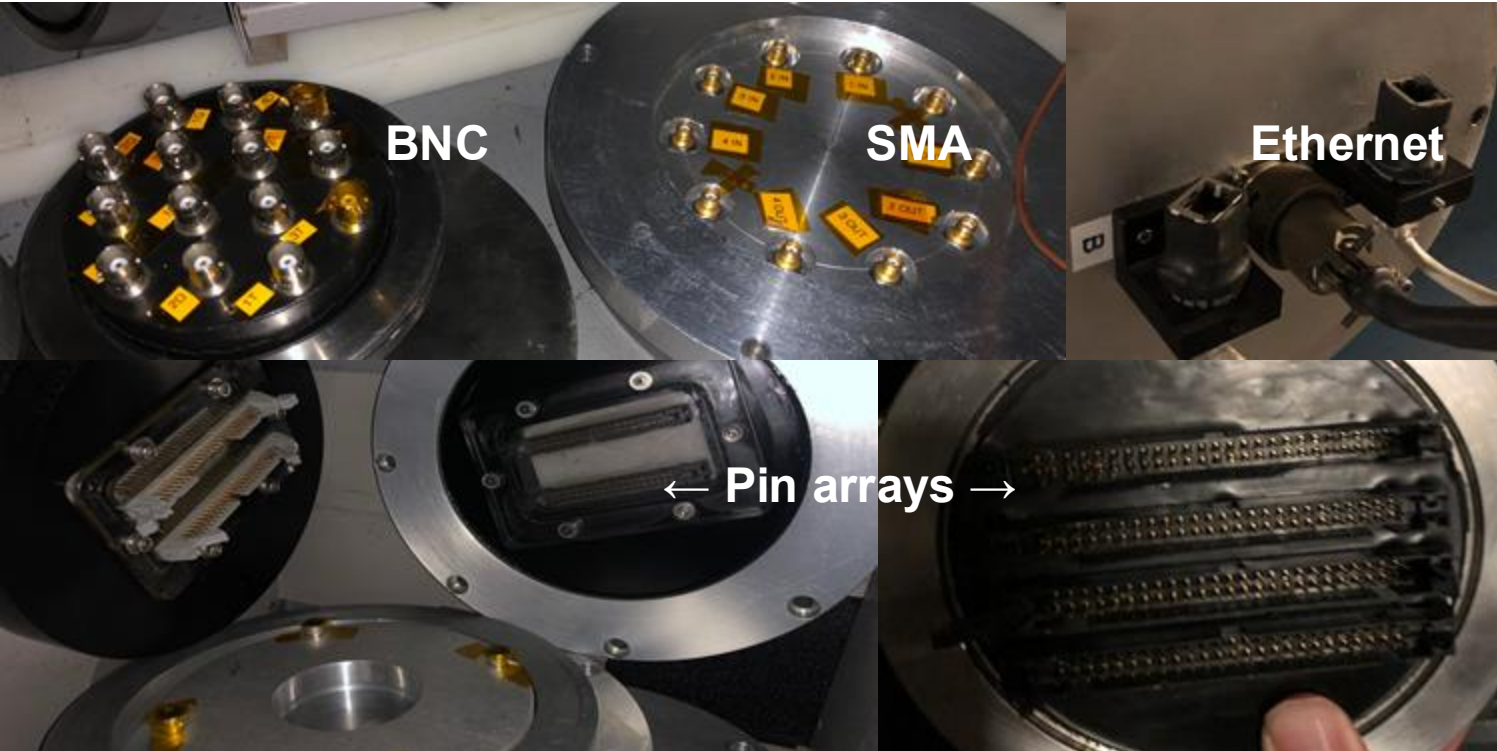
Courtesy  
NASA GSFC



# Vacuum chamber bulkhead connections

More info:

[88-Inch Cyclotron - Heavy Ions \(lbl.gov\)](#)



1

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Thru hole

2 13/16"

2 13/16"

2 13/16"

4-40 Screws

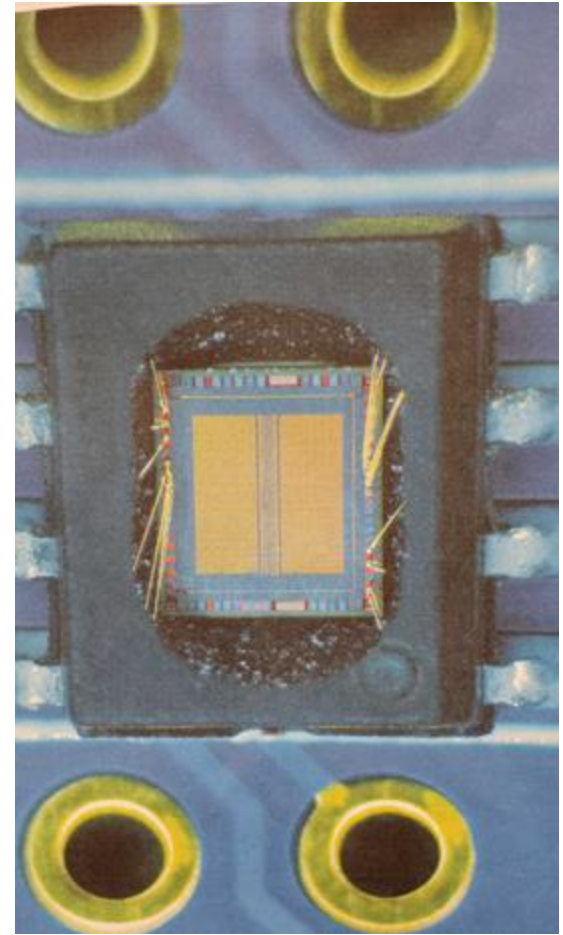
4 5/16"

**4B Cooling Plate**

Technical drawing of a circular foundation. The main view shows a circular foundation with a diameter of  $\phi 4,000 \pm 0/0$ . The foundation is supported by a base with a width of  $4,500 \pm 0/0$ . The base has a thickness of  $250 \pm 0/0$ . The foundation is surrounded by a concrete slab with a thickness of  $250 \pm 0/0$ . The drawing includes dimensions for the foundation's position relative to the building's centerline and the base's edge. A section line A-A is shown on the right side of the drawing.

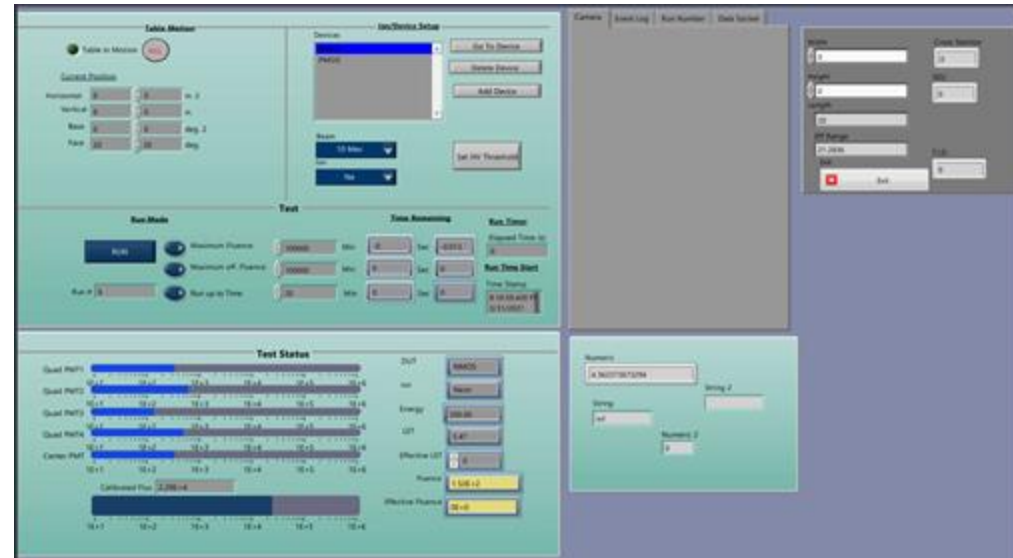
# Before heading to California...

- Decapsulate your parts as soon as possible
- Ship your gear early
- Checked baggage has to be  $\leq 99\text{lb}$
- Request specific ions if necessary



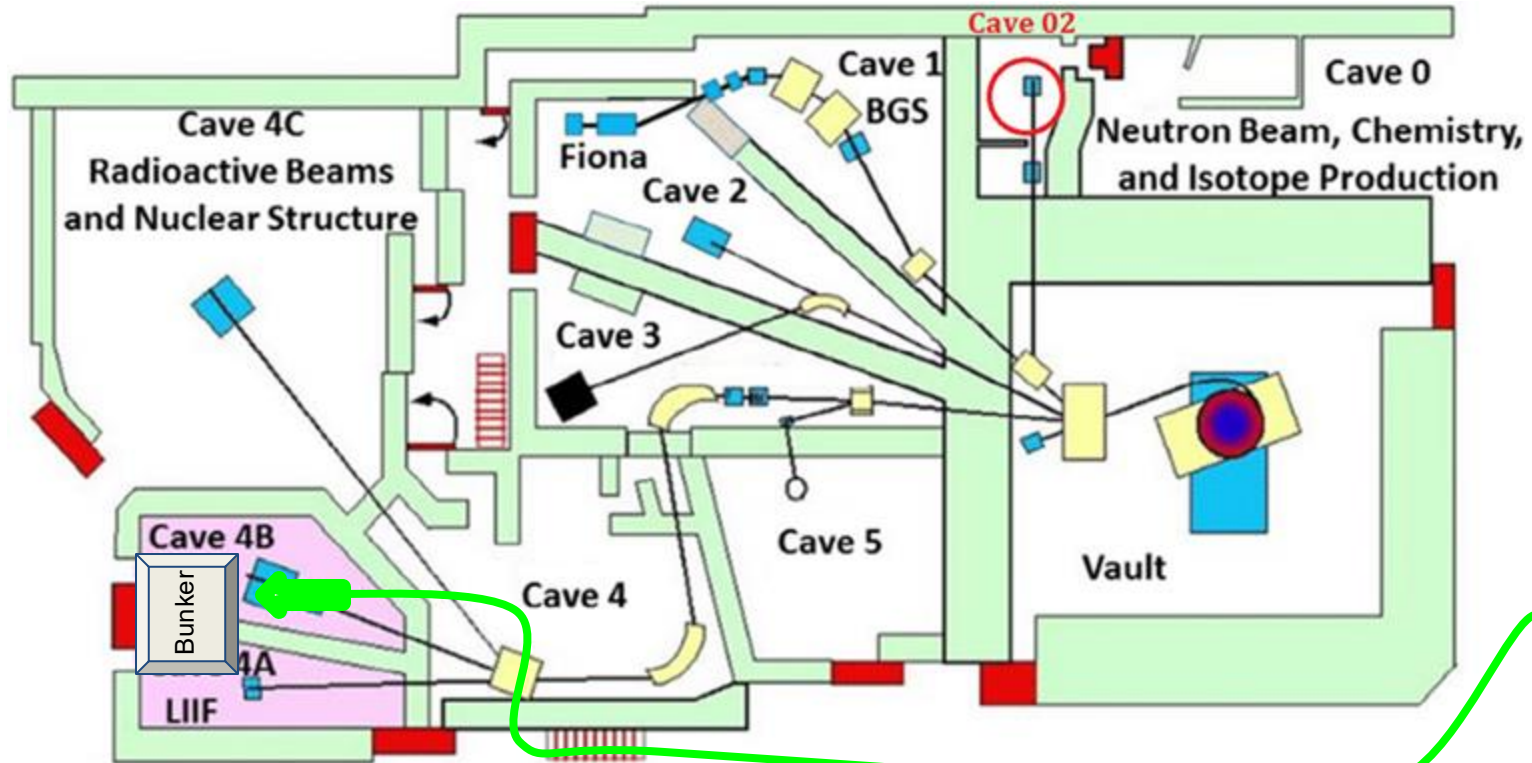
# Tips on being prepared

- Familiarize yourself with the software
- Bring snacks and something to kill time
- Rest as much as possible beforehand

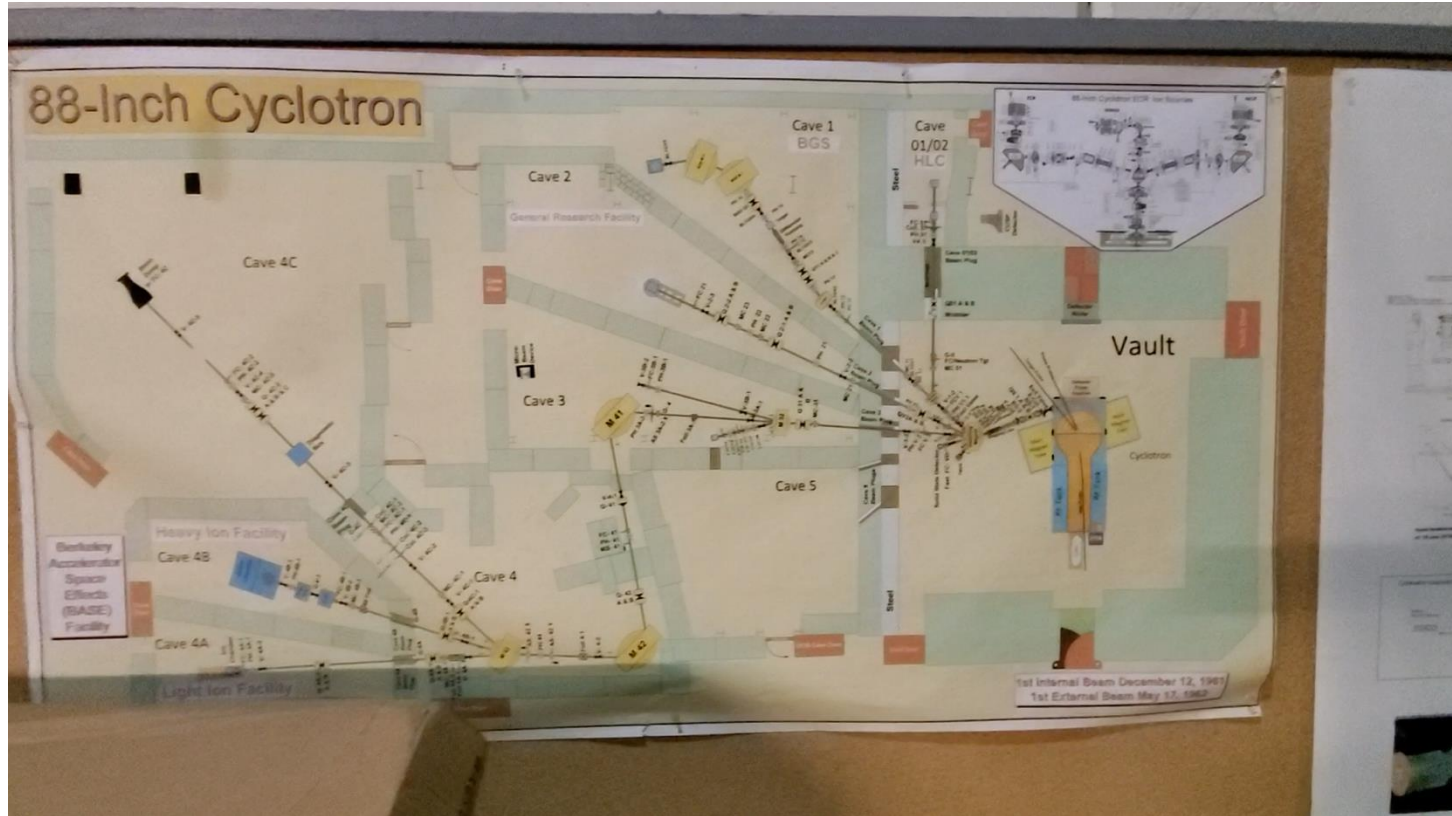




# Walking to the Bunker



# Walking to the Bunker



# Cave 4B



# Getting data

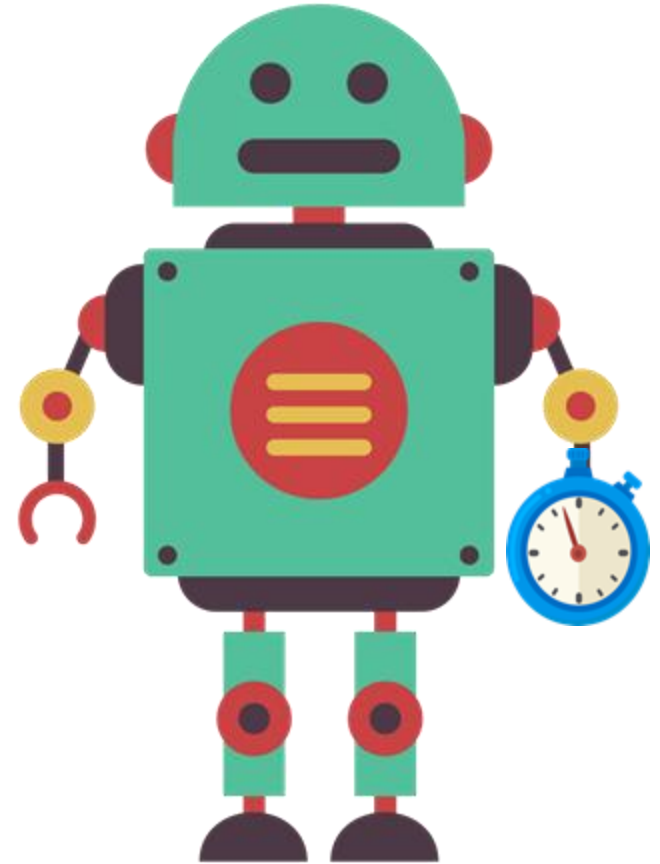
- Usually tests are broken up into short runs 1 to 5 minutes long
- You can do longer runs, you just need to plan accordingly
- Make sure that all data logs have the same run numbers
- Periodically check that the run numbers are in sync
- Spreadsheets are great!
- You can also generate them automatically with scripts

	A	B	C	D	E	F	G	H	I	J	K	L	M	N	O	P	Q	R	S	T	U	V	W
1	#	Ion	LET (er DUTs)	File	Dist	Time	VDD (V)	Fluence (cm	Avg I	Peak	A1 SEUs	A2 SEUs	A3 SEUs				C1 SEUs	C2 SEUs	C3 SEUs	Dose (rac	TID (krac	SEU XS (1)	SEU XS (2)
2	0	N	1.16	H01, H02, H0: data/sram/seu/H_check.csv	1	60	0.7	4.20E+06			0*									78.05	0.08	#DIV/0!	
3	1	N	1.16	H01, H02, H0: data/sram/seu/H_check.csv	1	60	0.7	5.32E+06			0*									98.86	0.18	#DIV/0!	
4	2	Ar	7.27	H01, H02, H0: data/sram/seu/H_Ar.csv	1	60	0.7	5.22E+06			144384	129024	137216				11264			607.95	0.78	2.62E-02	
5	3	Ar	7.27	H01, H02, H0: data/sram/seu/H_Ar.csv	1	60	0.7	5.46E+06			8192	7168	14336				142336			635.90	1.42	1.81E-03	
6	4	Ar	7.27	H01, H02, H0: data/sram/seu/H_Ar.csv	1	60	1	5.19E+06			6144	4096	3072				8192			604.46	2.03	8.55E-04	
7	5	Ar	7.27	H01, H02, H0: data/sram/seu/H_Ar.csv	1	60	1.3	5.34E+06			6144	2048	2048				4096			621.93	2.65	6.39E-04	
8	6	Ar	7.27	H01, H02, H0: data/sram/seu/H_Ar.csv	1	60	3.3	5.30E+06			3072	4096	3072				1024			617.27	3.26	6.44E-04	
9	7	Ar	7.27	H01, H02, H0: data/sram/seu/H_Ar_new.csv	1	60	0.7	5.70E+06												663.85	3.93	#DIV/0!	
10	8	Ar	7.27	H01, H02, H0: data/sram/seu/H_Ar_new.csv	1	60	1	5.71E+06			131072*	6755	131072*				12541			665.02	4.59	1.18E-03	
11	9	Ar	7.27	H01, H02, H0: data/sram/seu/H_Ar_new.csv	1	60	1.3	5.48E+06												638.23	5.23	#DIV/0!	
12	10	Ar	7.27	I01, I02, I03 data/sram/seu/I_Ar.csv	1	60	0.7	5.23E+06			24816	24745	23564							609.11	0.61	4.66E-03	
13	11	Ar	7.27	I01, I02, I03 data/sram/seu/I_Ar.csv	1	60	0.7	5.11E+06			24476	23879	22624							595.14	1.20	4.63E-03	
14	12	Ar	7.27	I01, I02, I03 data/sram/seu/I_Ar.csv	1	60	0.6	5.18E+06			21601	21923	20889							603.29	1.81	4.14E-03	
15	13	Ar	7.27	I01, I02, I03 data/sram/seu/I_Ar.csv	1	60	1.5	6.36E+06			20691	18395	16824							740.72	2.55	2.93E-03	
16	14	Ar	7.27	I01, I02, I03 data/sram/seu/I_Ar.csv	1	60	2.4	1.33E+05												15.49	2.56	#DIV/0!	
17	15	Ar	7.27	I01, I02, I03 data/sram/seu/I_Ar.csv	1	11	2.4	4.52E+05			????									52.64	2.62	#DIV/0!	
18	16	Ar	7.27	I01, I02, I03 data/sram/seu/I_Ar.csv	1	10	2.4	4.36E+05			Suspected latchup									50.78	2.67	#DIV/0!	



# Getting data

- Automate, automate, automate!
- This will save a lot of time and headache
- Use Python, MATLAB, VBA, or whatever tools are available
- Minimize user interactions
- Move quickly - time is a commodity
- Prioritize the most relevant data and optimize the run order
- Consider testing multiple parts or conditions simultaneously



# Acronyms

- B: Magnetic Field
- BNL: Brookhaven National Laboratory
- $\delta$ : Density
- FRIB: Facility for Rare Isotopes Beam
- IU: Indiana University
- LBNL: Lawrence Berkeley National Laboratory
- LET: Linear Energy Transfer
- $LET_{TH}$ : Threshold LET
- LINAC: Linear accelerator
- MSU: Michigan State University
- N: Number of Events or Particles
- NSRL: NASA Space Radiation Laboratory
- $Q_{CRIT}$ : Critical Charge
- RF: Radio Frequency
- RPP: Rectangular Parallel Piped
- s: Path Length (& sometimes range)
- $\sigma$ : Cross section
- $\sigma_{SAT}$ : Saturated  $\sigma$
- S: Shape Parameter in Weibull Distribution
- SEE: Single Event Effects
- SRIM: Stopping Range of Ions in Matter
- SUESS: TAMU's Cyclotron Institute  
Radiation Effects Facility Control Software
- SV: Sensitive Volume
- t: Thickness
- $\theta$  : Incident Angle
- TAMU: Texas A&M University
- TID: Total Ionizing Dose
- TRIUMF: Tri-University Meson Facility
- TvdG: Tandem Van der Graff
- W: Width Parameter in Weibull Distribution
- x: Length of SV
- y: Width of SV
- z: Depth of SV
- Z: Atomic Number